



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of

: **Confirmation No. 7872**

Tatsuki NOGIWA et al.

: Attorney Docket No. 2004_0601A

Serial No. 10/825,335

: Group Art Unit 1734

Filed April 16, 2004

: Examiner George R. Kock

SUBSTRATE SUPPORT JIG, CIRCUIT
BOARD PRODUCTION APPARATUS,
AND METHOD OF PRODUCING
CIRCUIT BOARD

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

ELECTION OF INVENTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of July 3, 2006, applicant in the above-referenced US Patent application hereby elects Group I directed to claims 1-12. Should the Examiner require anything further before the issuance of a First Office Action on the Merits he is respectfully requested to contact the applicants' undersigned representative.

Respectfully submitted,

Tatsuki NOGIWA et al.

By: 

Nils E. Pedersen
Registration No. 33,145
Attorney for Applicants

NEP/rlg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
July 13, 2006